Status of the Claims

- 1. (Original) A cutting apparatus, in particular a microtome or an ultramicrotome, for cutting specimens, comprising an observation device, in particular a stereomicroscope with an objective, a unit base, a knife carrier, an X-Y stage on which the knife carrier is mounted, a linear guide for displacement of the X-Y stage and a plurality of mounting surfaces for the linear guide are milled, directly on the unit base.
- 2. (Withdrawn) The cutting apparatus as defined in Claim 1, wherein stiffening ribs, which are directed upward from a plane of the unit base, are provided in order to enhance stability.
- 3. (Original) The cutting apparatus as defined in Claim 1, wherein the objective has an increased working distance, in particular of 110 mm.
- 4. (Original) The cutting apparatus as defined in Claim 1, wherein the observation device comprises a pivoting device on which an illumination device is arranged in such a way that it also pivots as the observation device pivots.
- 5. (Withdrawn) The cutting apparatus as defined in Claim 1, wherein a plurality of operating knobs are provided that are arranged in stepped fashion with respect to one another in terms of their lateral position on the stereomicroscope.
- 6. (Original) The cutting apparatus as defined in Claim 1, wherein a unit hood is provided whose corners are recessed in such a way that upon pivoting of the

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stereomicroscope about its pivot axis, the illumination device and the stereomicroscope can

be moved past the unit hood with no contact between them.

7. (Original) A microtome or an ultramicrotome, for cutting specimens, comprising a

stereomicroscope with an objective, wherein the objective has an increased working

distance, of 110 mm, a unit base, a knife carrier, an X-Y stage on which the knife carrier is

mounted, a linear guide for displacement of the X-Y stage, and a plurality of mounting

surfaces for the linear guide are milled, directly on the unit base.

8. (Original) A microtome or an ultramicrotome, for cutting specimens, comprising: a

stereomicroscope with an objective, wherein the objective has an increased working

distance, of 110 mm, an illumination device is arranged in such a way that it also pivots as

the stereomicroscope pivots, a unit base, a knife carrier, an X-Y stage on which the knife

carrier is mounted, a linear guide for displacement of the X-Y stage, and a plurality of

mounting surfaces for the linear guide are milled, directly on the unit base.

9. (Withdrawn) A microtome or an ultramicrotome, for cutting specimens, comprising a

stereomicroscope with an objective, wherein the objective has an increased working

distance, of 110 mm, a plurality of operating knobs that are arranged in stepped fashion

with respect to one another in terms of their lateral position on the stereomicroscope, a unit

base, a knife carrier, an X-Y stage on which the knife carrier is mounted, a linear guide for

displacement of the X-Y stage, and a plurality of mounting surfaces for the linear guide are

milled, directly on the unit base.

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10. (Original) A microtome or an ultramicrotome, for cutting specimens, comprising a

stereomicroscope with an objective, wherein the objective has an increased working

distance, of 110 mm, an illumination device is arranged in such a way that it also pivots as

the stereomicroscope pivots, a unit hood whose corners are recessed in such a way that

upon pivoting of the stereomicroscope about its pivot axis, the illumination device and the

stereomicroscope can be moved past the unit hood with no contact between them, a unit

base, a knife carrier, an X-Y stage on which the knife carrier is mounted, a linear guide for

displacement of the X-Y stage, and a plurality of mounting surfaces for the linear guide are

milled, directly on the unit base.